



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Min-Lung HUANG et al.

Confirmation No: 8687

Appl. No.

10/820,855 April 9, 2004

Filed Title

Under Bump Metallization Structure Of A Semiconductor Wafer

TC/A.U.

2813

Examiner

D. S. Blum

Docket No.:

HUAN3262/REF

Customer No:

23364

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants request that the period for response to the outstanding official action in this case be extended pursuant to 37 CFR 1.136 (a) for ONE (1) month to August 11, 2006.

The fee set in 37 CFR 1.17(a)(1) for a one month extension of time is \$120.00 and a check in this amount is submitted herewith. Please charge any additional fee required for this extension to Deposit Account No. 02-0200.

Respectfully submitted, BACON & THOMAS, PLLC

Scott-A F

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August 8, 2006